

F I G . 1

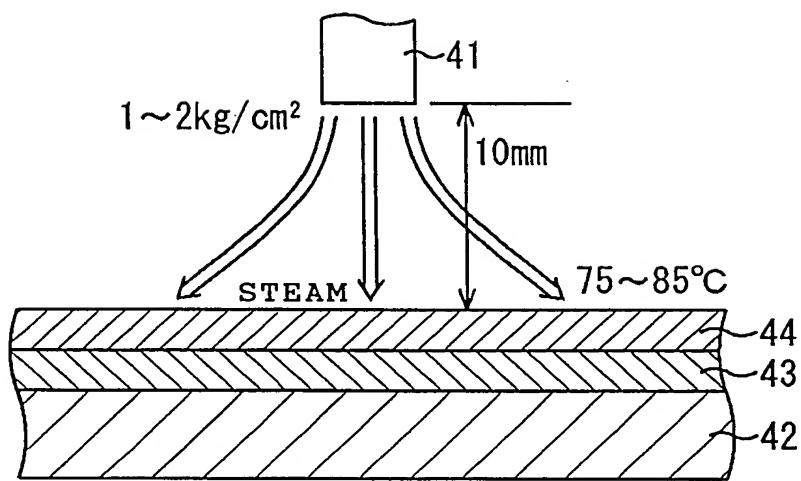
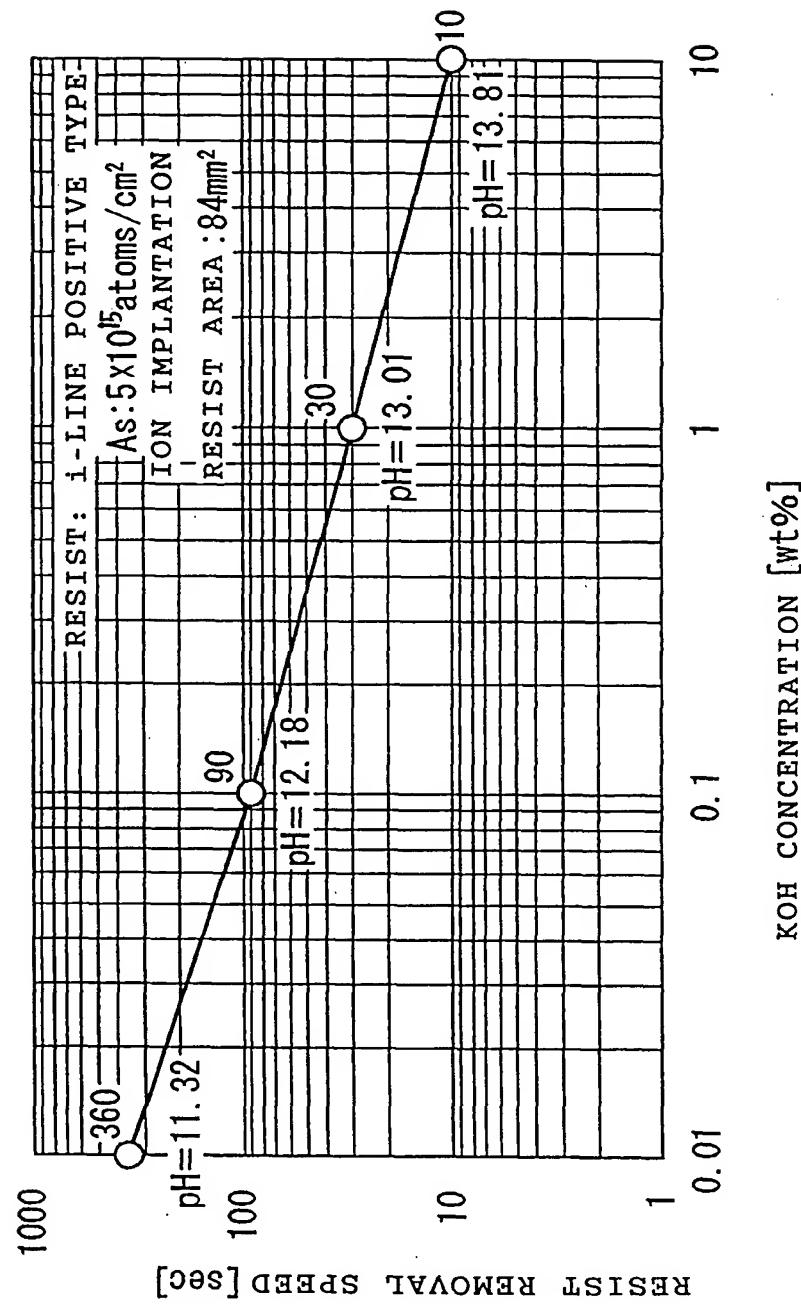
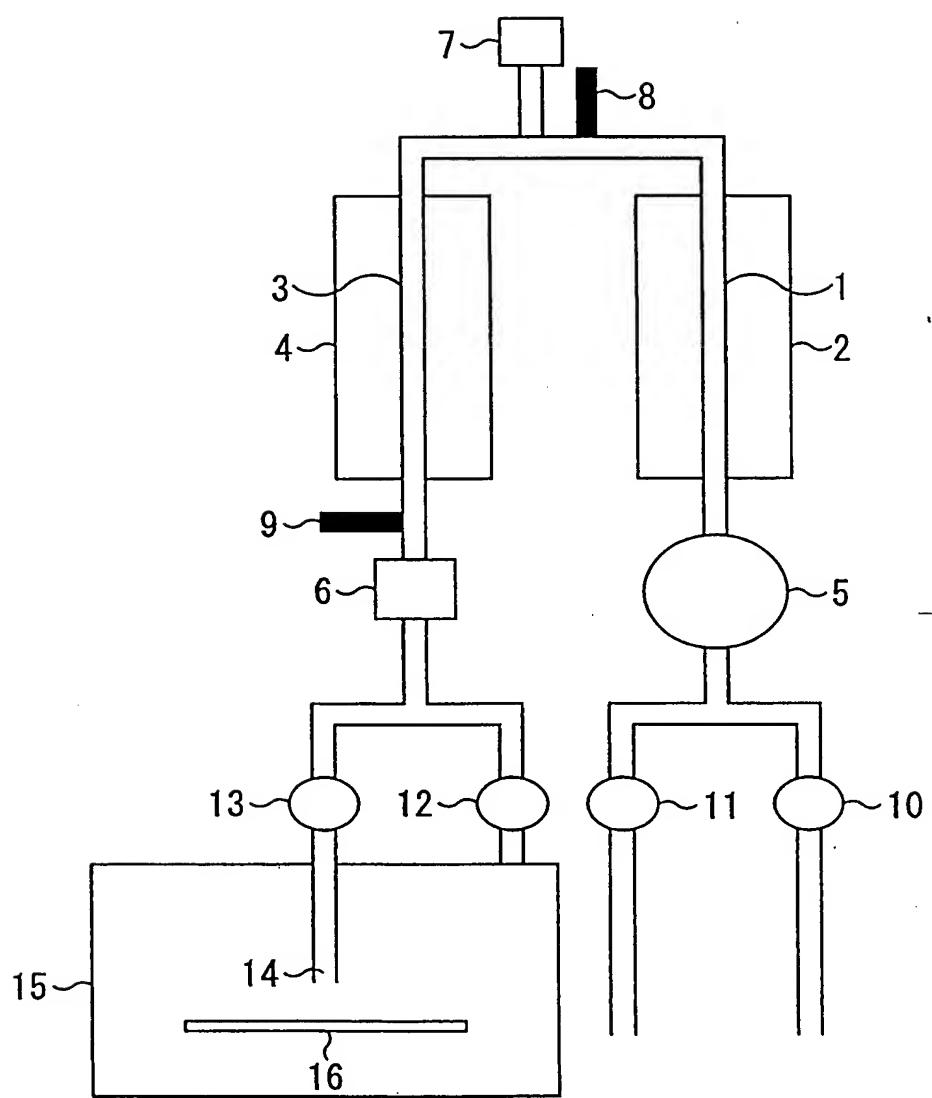


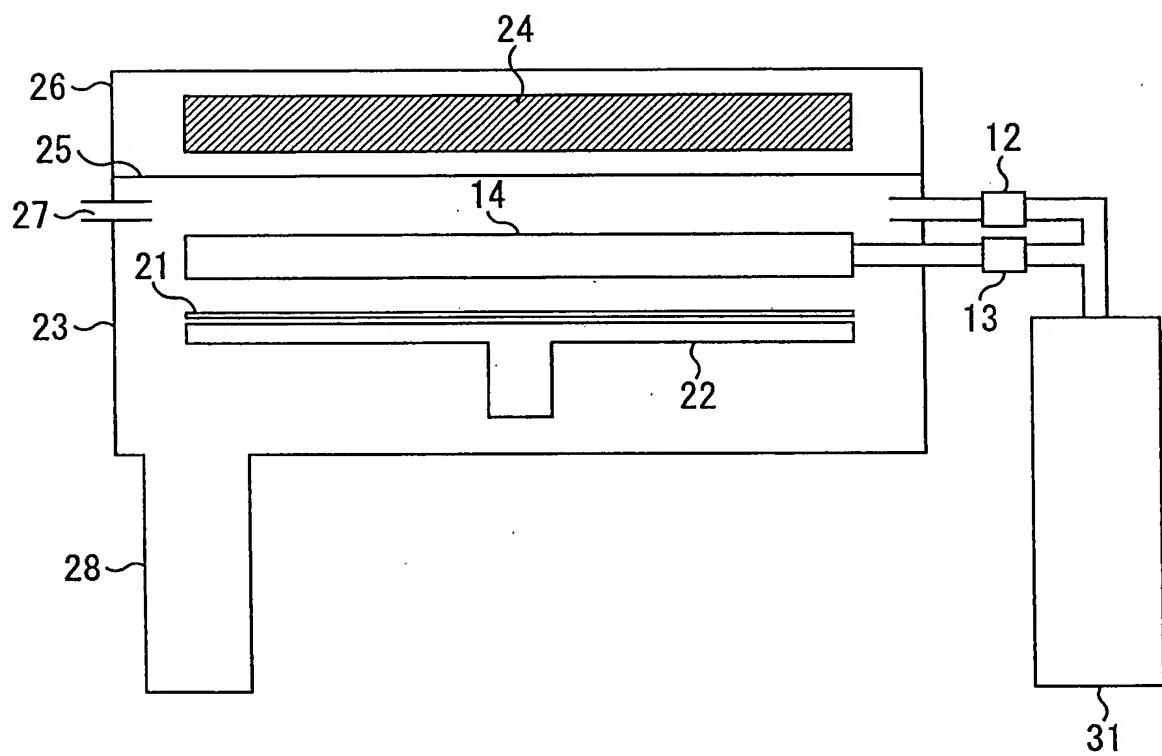
FIG. 2



F I G . 3

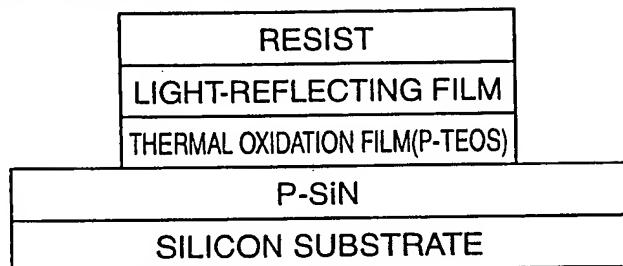


F I G . 4



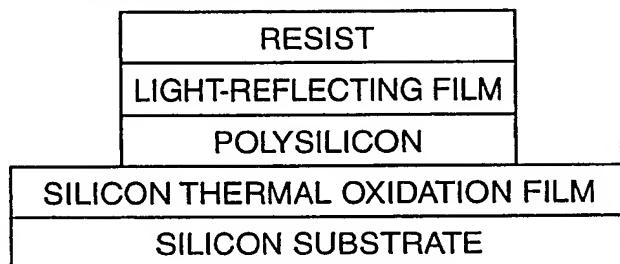
F I G. 5 A

OXIDE FILM DRY-ETCHED SURFACE



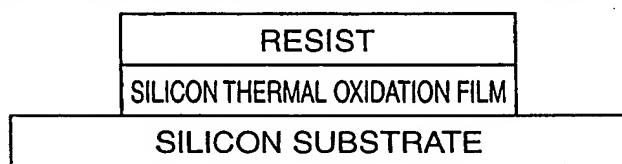
F I G. 5 B

GATE ELECTRODE ETCHED SURFACE



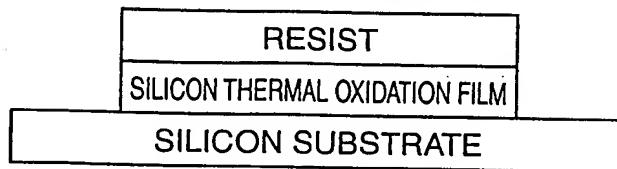
F I G. 5 C

OXIDE FILM ETCHED /ION-IMPLANTED SURFACE[P/80KeV/6E15]



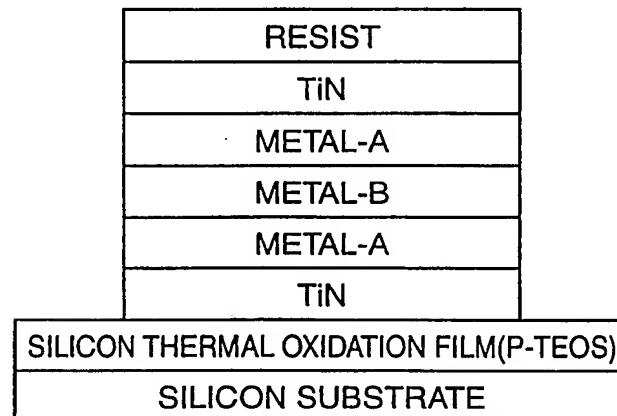
F I G . 5 D

OXIDE FILM WET-ETCHED SURFACE



F I G . 5 E

METAL WIRING ETCHED/ION-IMPLANTED SURFACE



F I G . 6

